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RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 3652

PATENT APPLICATION  
Docket No.: 4591-374  
Client Ref. No.: IH13086-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Kwang-Ho HAN et al.

Serial No.: 10/775,958 Examiner: Keenan, James W.

Filed: February 9, 2004 Group Art Unit: 3652

Confirmation No.: 1600

For: APPARATUS AND METHOD FOR POSITIONING  
SEMICONDUCTOR SUBSTRATE

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Responsive to the Final Office Action, Paper No. 20080514, dated May 21, 2008, please amend the application as follows.

- **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.
- **Remarks/Arguments** begin on page 7 of this paper.